

AD-A039 289

AEROSPACE CORP EL SEGUNDO CALIF MATERIALS SCIENCES LAB F/G 9/5
SINGLE ION COUNTING IN HIGH-RESOLUTION MASS SPECTROMETRY.(U)

APR 77 F M WACHI, D E GILMARTIN

F04701-76-C-0077

UNCLASSIFIED

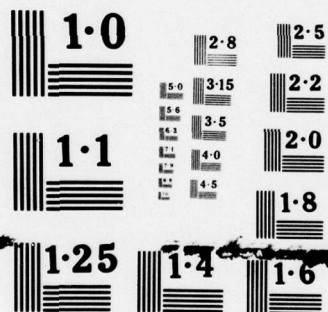
TR-0077(2250-10)-3

SAMSO-TR-77-71

NL

1 OF 1
ADA
039289





NATIONAL BUREAU OF STANDARDS
MICROCOPY RESOLUTION TEST CHART

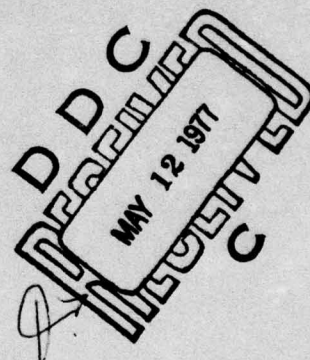
AD A 039289

Single Ion Counting in High-Resolution Mass Spectrometry

Materials Sciences Laboratory
The Ivan A. Getting Laboratories
The Aerospace Corporation
El Segundo, Calif. 90245

7 April 1977

Interim Report



APPROVED FOR PUBLIC RELEASE;
DISTRIBUTION UNLIMITED

Prepared for
SPACE AND MISSILE SYSTEMS ORGANIZATION
AIR FORCE SYSTEMS COMMAND
Los Angeles Air Force Station
P.O. Box 92960, Worldway Postal Center
Los Angeles, Calif. 90009

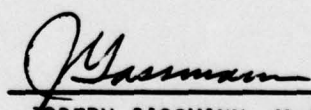
AD NO. _____
DDC FILE COPY

This report was submitted by The Aerospace Corporation, El Segundo, CA 90245, under Contract F04701-76-C-0077 with the Space and Missile Systems Organization, Deputy for Advanced Space Programs, P.O. Box 92960, Worldway Postal Center, Los Angeles, CA 90009. It was reviewed and approved for The Aerospace Corporation by W. C. Riley, Director, Materials Sciences Laboratory. Lieutenant A. G. Fernandez, YAPT, was the Deputy for Advanced Space Programs project engineer.

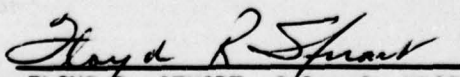
This report has been reviewed by the Information Office (OI) and is releasable to the National Technical Information Service (NTIS). At NTIS, it will be available to the general public, including foreign nations.

This technical report has been reviewed and is approved for publication. Publication of this report does not constitute Air Force approval of the report's findings or conclusions. It is published only for the exchange and stimulation of ideas.


ARTURO G. FERNANDEZ, Lt, USAF
Project Officer


JOSEPH GASSMANN, Maj, USAF

FOR THE COMMANDER


FLOYD R. STUART, Colonel, USAF
Deputy for Advanced Space Programs

Accession for	Write Section	☐
NTIS	Buff Section	☐
DISSEMINATED		
JUSTIFICATION		
BY		
DATE		
BUSINESS AFFIDAVIT OF DISSEMINATION		
DATE		
BY		

UNCLASSIFIED

SECURITY CLASSIFICATION OF THIS PAGE (When Data Entered)

REPORT DOCUMENTATION PAGE		READ INSTRUCTIONS BEFORE COMPLETING FORM	
1. REPORT NUMBER SAMS0-TR-77-71	2. GOVT ACCESSION NO.	3. RECIPIENT'S CATALOG NUMBER 9	
4. TITLE (and Subtitle) SINGLE ION COUNTING IN HIGH-RESOLUTION MASS SPECTROMETRY.		5. TYPE OF REPORT & PERIOD COVERED Interim rept.	
7. AUTHOR(s) Francis M. Wachi and Donald E. /Gilmartin		6. PERFORMING ORG. REPORT NUMBER TR-0077(2250-10)-3	
9. PERFORMING ORGANIZATION NAME AND ADDRESS The Aerospace Corporation El Segundo, Calif. 90245		8. CONTRACT OR GRANT NUMBER(s) F04701-76-C-0077	
11. CONTROLLING OFFICE NAME AND ADDRESS Space and Missile Systems Organization Air Force Systems Command Los Angeles, Calif. 90009		10. PROGRAM ELEMENT, PROJECT, TASK AREA & WORK UNIT NUMBERS	
14. MONITORING AGENCY NAME & ADDRESS (if different from Controlling Office)		12. REPORT DATE 7 April 1977	
		13. NUMBER OF PAGES 13 16p.	
		15. SECURITY CLASS. (of this report) Unclassified	
		15a. DECLASSIFICATION/DOWNGRADING SCHEDULE	
16. DISTRIBUTION STATEMENT (of this Report) Approved for public release; distribution unlimited.			
17. DISTRIBUTION STATEMENT (of the abstract entered in Block 20, if different from Report) 403 644			
18. SUPPLEMENTARY NOTES			
19. KEY WORDS (Continue on reverse side if necessary and identify by block number) Ion Counting Mass Spectrometry High Resolution			
20. ABSTRACT (Continue on reverse side if necessary and identify by block number) A modification that permits the utilization of an air-stable, continuous-dynode electron multiplier that can be used either as an ion-counting or as an ion-current measuring device without jeopardizing the photoplate ion-detection capability of the high-resolution mass spectrometer is described.			

DD FORM 1473
(FACSIMILE)UNCLASSIFIED
SECURITY CLASSIFICATION OF THIS PAGE (When Data Entered)

PREFACE

The authors wish to thank A. Y. Lu for helpful suggestions and technical assistance.

SINGLE ION COUNTING IN HIGH-RESOLUTION MASS SPECTROMETRY

Recently, mass spectrometric analysis of trace quantities of residual gases in traveling-wave tubes necessitated the development of an ion-counting detector system for the high-resolution mass spectrometer. The spectrometer is a double-focusing instrument of the Mattauch-Herzog geometry (Consolidated Electrodynamics Corp., Model 21-110B) equipped with an ion-detection system consisting of a photoplate, Faraday cup, and electron multiplier. High-resolution mass spectrometry was required to differentiate hydrocarbon fragments from other residual gases such as nitrogen, oxygen, carbon monoxide, argon, carbon dioxide, hydrogen cyanide, nitrous oxide, and nitrogen dioxide. The mass resolution of an ultrasensitive, quadrupole-type residual gas analyzer equipped with an ion-counting detector¹ is inadequate for this application. Furthermore, the need for the quantitative determination of the partial pressures of the residual gases imposed a severe limitation on the use of the direct-current technique of measuring ion currents with the existing electron multiplier because of mass discrimination effects exhibited by the conversion dynode²⁻⁶ and the poor precision and accuracy in measuring the very small ion currents that result from background noise interferences and drift in multiplier gain. A modification that permits the utilization of an air-stable electron multiplier that can be used either as an ion-counting or as an ion-current measuring

device without jeopardizing the photoplate ion-detection capability of the high-resolution mass spectrometer is described in this report.

The original electron multiplier supplied with the mass spectrometer is a 16-stage Allen type with beryllium-copper dynodes. This electron multiplier is inadequate for use in ion-counting techniques because of its inherent high noise level⁷ and its poor frequency response, which precludes the acquisition of data at sampling rates greater than 10 kHz that are required for computer interfacing under high-resolution operation. These limitations have been circumvented by replacing the existing electrical detection system, consisting of the Faraday cup and the Allen-type electron multiplier, with a Channeltron[®]⁸ electron multiplier (Galileo Electro-Optics Corp., Model 4730) assembly⁹ shown in Fig. 1. This detector assembly is attached to the mass spectrometer with a specially designed adapter¹⁰ that aligns the aperture of the Channeltron electron multiplier (CEM) with the collector slit and yet does not jeopardize the photoplate ion-detection capability of the spectrometer. A photograph of the modified combination ion-detection system is shown in Fig. 2.

Although it is not shown in Fig. 1, a 0.002- μ F, 6-kV capacitor is attached between the negative high-voltage biased end of the electron multiplier and instrument ground to remove high-frequency voltage spikes from the power supply. The CEM is protected from stray magnetic fields by the soft iron shield; its potential is also maintained at instrument ground. Electrical power to the CEM is provided by a solid-state, high-voltage power

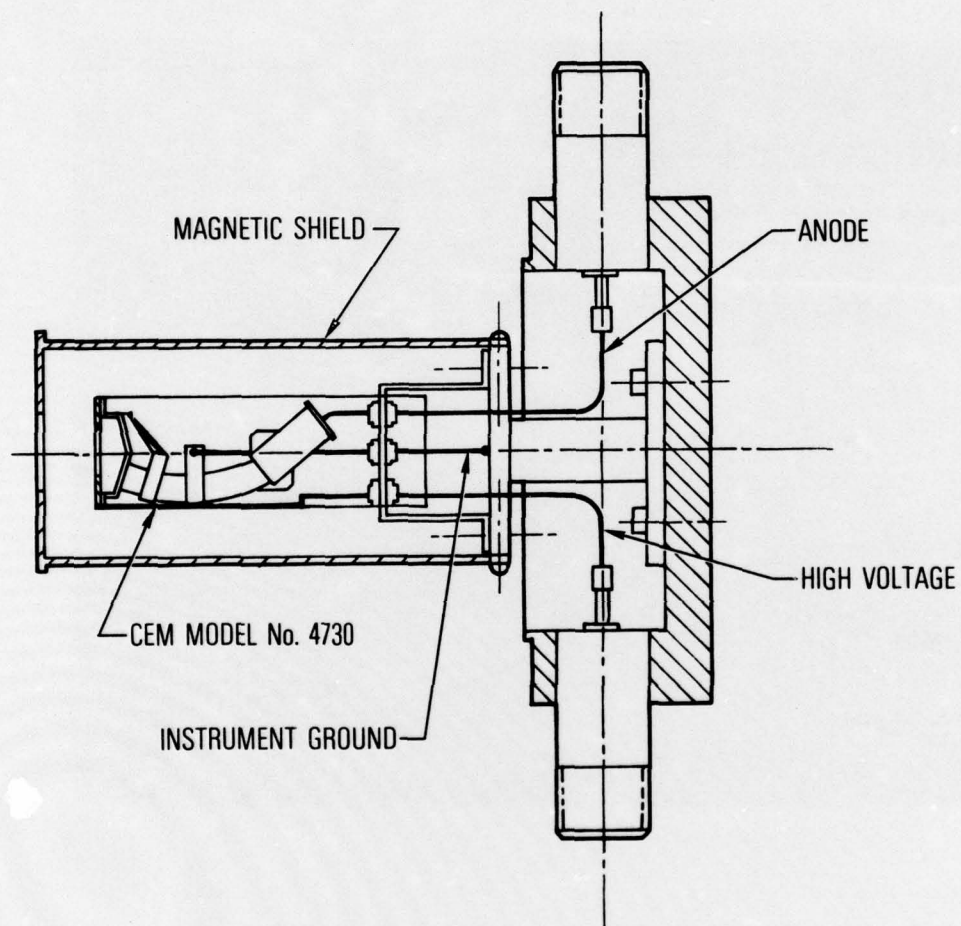


Fig. 1. Schematic of Channeltron Electron Multiplier Assembly

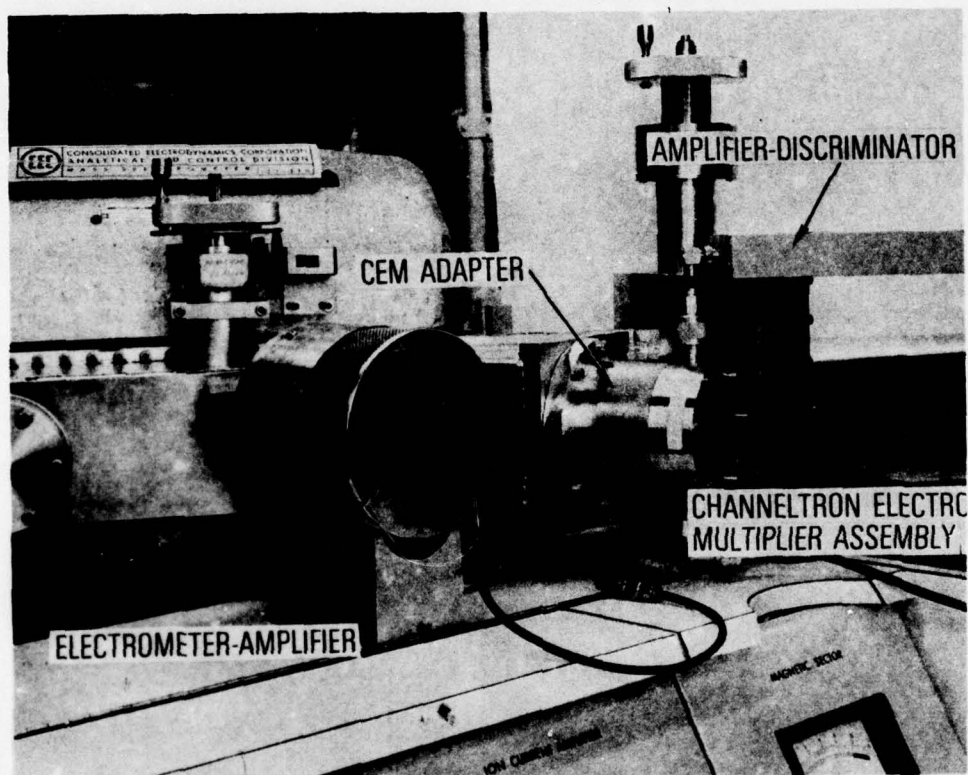


Fig. 2. Modified Combination Ion-Detection System

supply (SSR Instruments Co. , Model 1106-10). The anode of the CEM is connected to the pulse-counting electronic system, consisting of SSR Instruments Model 1120-01 amplifier-discriminator (10-nsec pulse pair resolution) and Model 1110 digital synchronous computer. The digital data are recorded either onto a magnetic tape or a digital recorder for further processing. The performance characteristic of this ion-counting detector system is illustrated in Fig. 3. The multiplier dark count plus the electronic system noise at applied voltages of 2 kV and 3 kV are 0.005 counts/sec and 0.03 counts/sec, respectively. The CEM has exhibited minimal degradation in overall multiplier gain even after exposure to air for over a month during 14 months of operation. The gain measured at an applied voltage of 2.5 kV decreased from 8×10^7 to 4.5×10^7 .

Ion counting not only permits the measurement of very small ion currents with greater precision and accuracy but is also essentially free of effects resulting from mass discrimination and drift due to changes in multiplier gain. Another important feature of this modification is that it permits the rapid conversion from pulse counting to analog mode of ion detection. The conversion consists of removing the amplifier-discriminator and hooking up the electrometer-amplifier whose output may be fed directly into other analog-to-digital converters, i. e. , the original system can be restored in minutes.

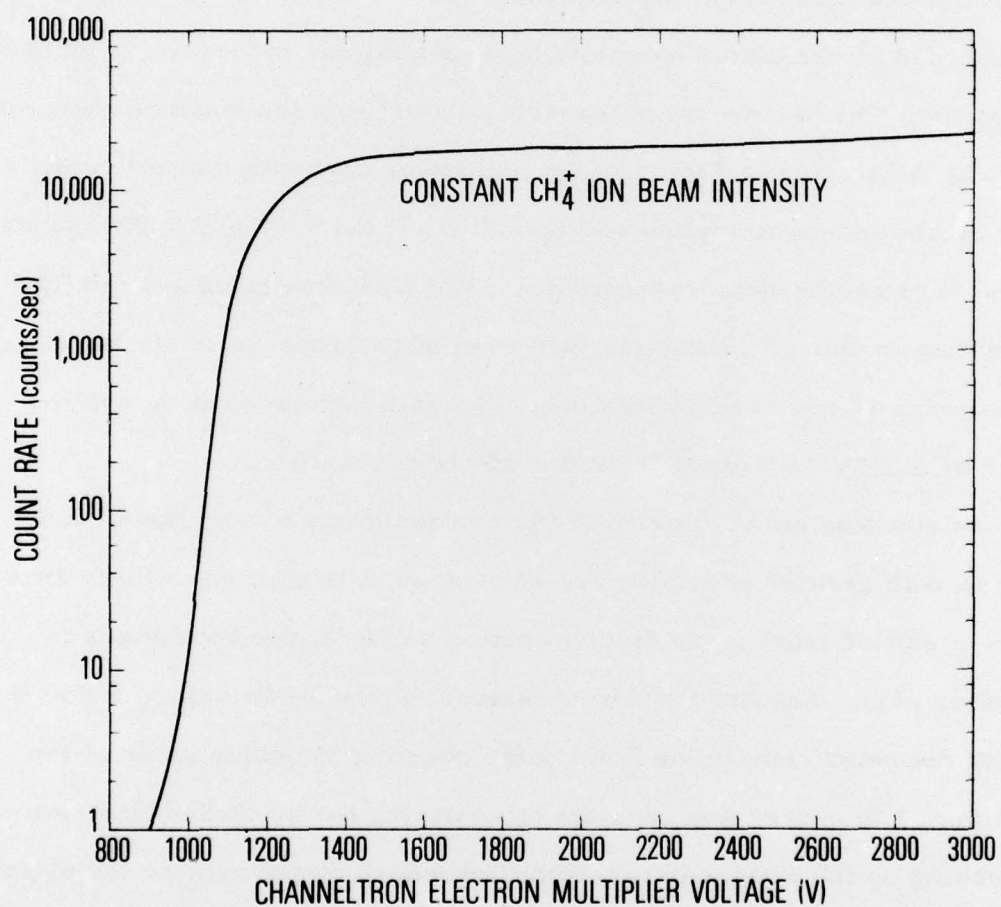


Fig. 3. Count Rate As a Function of Electron Multiplier Voltage

REFERENCES

1. C. R. Winkelman and H. G. Davidson, J. Vac. Sci. Technol. **12**, 435 (1975).
2. M. G. Inghram and R. J. Hayden, Nucl. Sci. Series, Report 14 (1954).
3. M. G. Inghram, R. Hayden, and D. Hess, Natl. Bur. Std. (U.S.) Cir., 522 (1951).
4. H. Stanton, W. Chupka, and M. G. Inghram, Rev. Sci. Inst. **27**, 109 (1956).
5. R. C. Lao, R. Sander, and R. F. Pottie, Int. J. Mass Spectrometry Ion Phys. **10**, 309 (1972/73).
6. R. F. Pottie, D. L. Cocke, and K. A. Gingerich, Int. J. Mass Spectrometry Ion Phys. **11**, 41 (1973).
7. C. A. Stearns and F. J. Kohl, High-Temperature Mass Spectrometry-Vaporization of Group IVB Metal Carbides, NASA TN D-7613, Lewis Research Center, Cleveland, Ohio (April 1974).
8. Continuous-dynode, electrostatic-focusing electron multiplier produced by Galileo Electro-Optics Corp.
9. This entire assembly (Part No. 294790) is manufactured by DuPont Instruments for their Series 21-490 mass spectrometers.
10. Engineering drawings of the adapter (Appendix) may be obtained from one of the authors.

APPENDIX

Assembly instructions for the Channeltron[®] electron multiplier adapter for the mass spectrometer and rework instructions for the model 4730 CEM are presented.

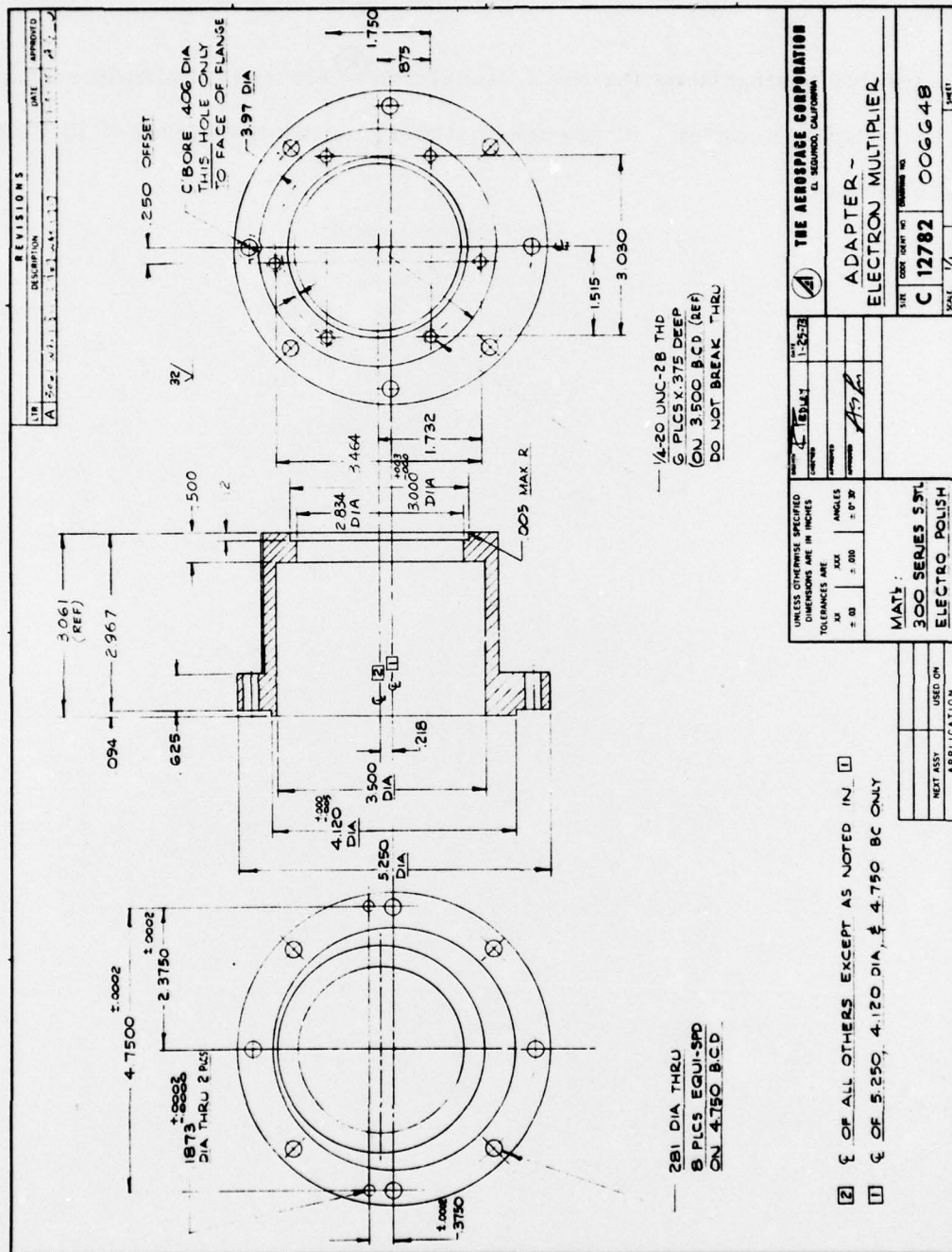


Fig. A-1. CEM Adapter for Mass Spectrometer

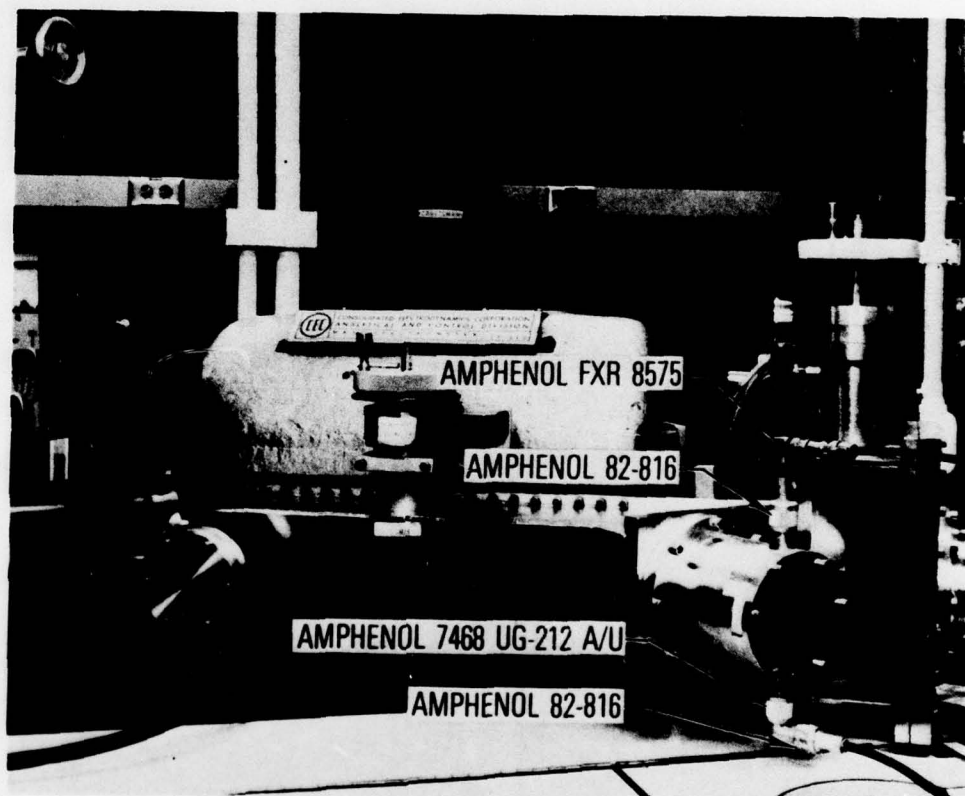


Fig. A-2. Electrical Connectors of CEM Assembly

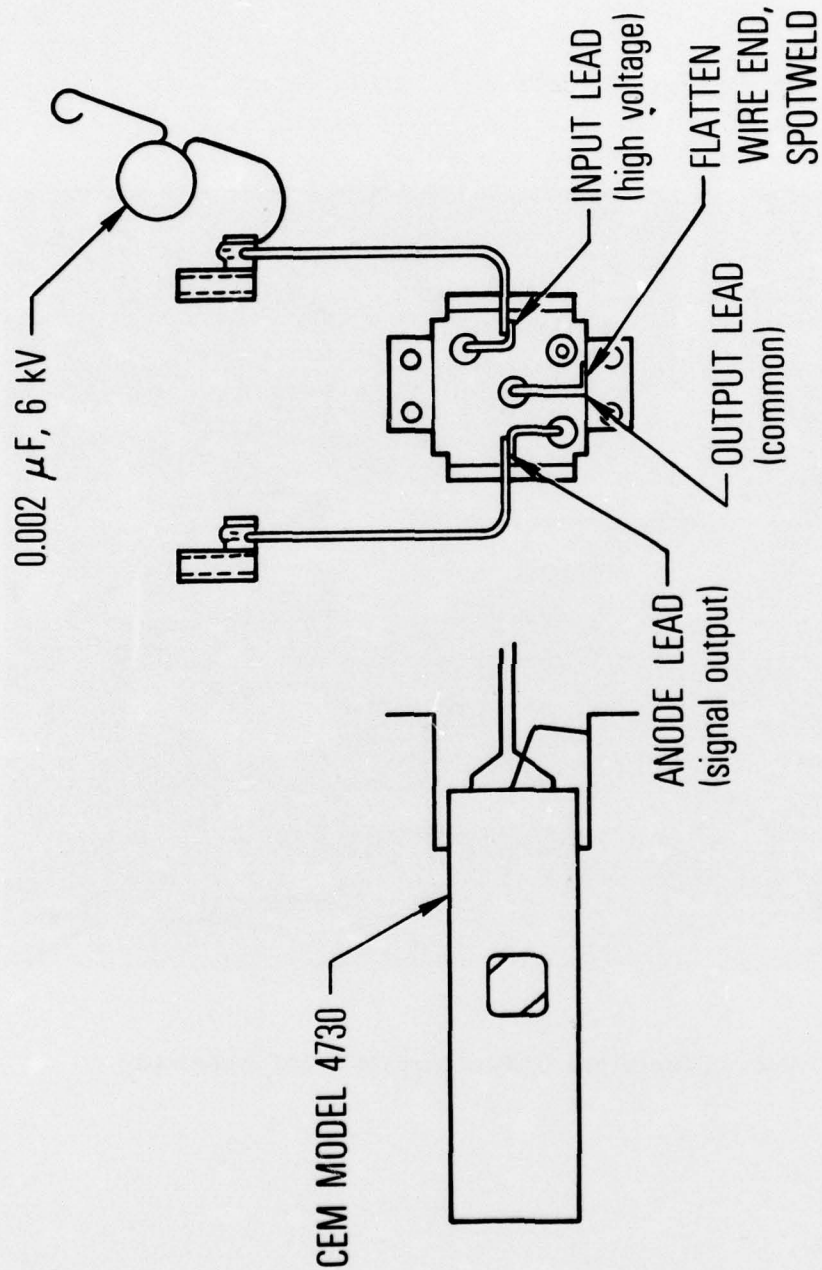


Fig. A-3. Schematic of Channeltron Rework

THE IVAN A. GETTING LABORATORIES

The Laboratory Operations of The Aerospace Corporation is conducting experimental and theoretical investigations necessary for the evaluation and application of scientific advances to new military concepts and systems. Versatility and flexibility have been developed to a high degree by the laboratory personnel in dealing with the many problems encountered in the nation's rapidly developing space and missile systems. Expertise in the latest scientific developments is vital to the accomplishment of tasks related to these problems. The laboratories that contribute to this research are:

Aerophysics Laboratory: Launch and reentry aerodynamics, heat transfer, reentry physics, chemical kinetics, structural mechanics, flight dynamics, atmospheric pollution, and high-power gas lasers.

Chemistry and Physics Laboratory: Atmospheric reactions and atmospheric optics, chemical reactions in polluted atmospheres, chemical reactions of excited species in rocket plumes, chemical thermodynamics, plasma and laser-induced reactions, laser chemistry, propulsion chemistry, space vacuum and radiation effects on materials, lubrication and surface phenomena, photo-sensitive materials and sensors, high precision laser ranging, and the application of physics and chemistry to problems of law enforcement and biomedicine.

Electronics Research Laboratory: Electromagnetic theory, devices, and propagation phenomena, including plasma electromagnetics; quantum electronics, lasers, and electro-optics; communication sciences, applied electronics, semiconducting, superconducting, and crystal device physics, optical and acoustical imaging; atmospheric pollution; millimeter wave and far-infrared technology.

Materials Sciences Laboratory: Development of new materials; metal matrix composites and new forms of carbon; test and evaluation of graphite and ceramics in reentry; spacecraft materials and electronic components in nuclear weapons environment; application of fracture mechanics to stress corrosion and fatigue-induced fractures in structural metals.

Space Sciences Laboratory: Atmospheric and ionospheric physics, radiation from the atmosphere, density and composition of the atmosphere, aurorae and airglow; magnetospheric physics, cosmic rays, generation and propagation of plasma waves in the magnetosphere; solar physics, studies of solar magnetic fields; space astronomy, x-ray astronomy; the effects of nuclear explosions, magnetic storms, and solar activity on the earth's atmosphere, ionosphere, and magnetosphere; the effects of optical, electromagnetic, and particulate radiations in space on space systems.

THE AEROSPACE CORPORATION
El Segundo, California